

<b>Notice of References Cited</b>	Application/Control No. 10/738,416	Applicant(s)/Patent Under Reexamination LIU, CHIA-CHEN	
	Examiner DuyVu n. Deo	Art Unit 1765	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,847,068	01-2005	Chuang et al.	257/260
	B	US-6,562,681	05-2003	Tuan et al.	438/257
	C	US-2003/0087493	05-2003	Jenq et al.	438/265
	D	US-2004/0115882	06-2004	Hung et al.	438/257
	E	US-2002/0142545	10-2002	Lin, Chi-Hui	438/257
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.